



ITW

Attorney Docket No. 970.1011

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Toshiaki KAKEMURA et al.

Application No.: 10/529,362

Group Art Unit: 1792

Confirmation No. 4778

Filed: March 28, 2005

Examiner: BURKHART, ELIZABETH A

Confirmation No.: 4778

For: THIN FILM FORMING METHOD, THIN FILM FORMING DEVICE, AND THIN FILM FORMING PROCESS MONITORING METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

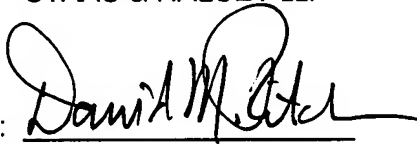
Sir:

This is responsive to the Office Action mailed June 9, 2008, and having a period for response set to expire on July 9, 2008. Applicants elect the invention of Group I and claims 1-5 related thereto. Applicants reserve the right to further prosecute without prejudice the non-elected inventions of Group II and Group III, and claims readable thereon.

If there are any additional fees associated with this Response, please charge the same to our Deposit Account No. 19-3935.

Respectfully submitted,

STAAS & HALSEY LLP

By: 
David M. Pitcher
Registration No. 25,908

Date: July 1, 2008

1201 New York Ave, N.W.
7th Floor
Washington, D.C. 20005
Telephone: (202) 434-1500
Facsimile: (202) 434-1501